

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

April 8, 2008

In re the application of:
S. Panda *et al.*

Docket No. FIS920030133US1
(also sometimes 175P012)

Filed: 11/25/2003

Art Unit: 1792

Application No.: 10/721,657

Examiner: Lan Vinh

For: Method Of Processing Wafers With
Resonant Heating

Confirmation No. 7420

AMENDMENT AND/OR REPLY TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action dated January 18, 2008 (the "Office Action"),
please consider the following amendment and remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.